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» Why is the number of results sometimes approximate?

» Why could it be that a certain patent document is not displayed in the results list?

» Why do I sometimes get results having a title which is not in English?

» Why do I sometimes get results which may not match my query?

» Why should I tick the "in my patents list" box?

» What is an XP document?

RESULT LIST

Approximately 80 results found in the Worldwide database for:
piezoelectric in the title AND bonding and (bend* or flex*) in the title or abstract
(Results are sorted by date of upload in database)

1	Multi-Layer Piezoelectric Element and Method for Manufacturing the Same	Inventor: KONDO MITSUO (JP); TERAZONO MASAKI (JP); (+2) EC: H01L41/047; H01L41/083 Publication info: US2007278907 - 2007-12-06	Applicant: KYOCERA CORP (JP) IPC: H01L41/083; F02M51/00; F02M51/06 (+11)
2	Large dimension, flexible piezoelectric ceramic tapes and methods to make same	Inventor: XU BAOMIN (US); BUHLER STEVEN A (US); (+5) EC: B06B1/06C3; G01L1/16; (+2) Publication info: EP1808896 - 2007-07-18	Applicant: XEROX CORP (US) IPC: H01L27/20; H01L41/09; B06B1/06 (+17)
3	High sensitivity, low noise piezoelectric flexural sensing structure	Inventor: ZOU LICHUN (US); DENG KEN K (US) EC: G01P15/09D Publication info: US2007119259 - 2007-05-31	Applicant: IPC: G01B7/16; G01B7/16
4	Electroding of ceramic piezoelectric transducers	Inventor: GAILUS DAVID W (US); HOISINGTON PAUL A (US) EC: B41J2/14D; B41J2/16D; (+1) Publication info: EP1667243 - 2006-06-07	Applicant: DIMATIX INC (US) IPC: H01L41/047; B41J2/14; H01L41/00 (+1)
5	PIEZOELECTRIC ELECTROACOUSTIC TRANSDUCER	Inventor: TAKESHIMA TETSUO (JP); YAMAUCHI MASAKAZU (JP); (+2) EC: H04R17/00; G10K9/125 Publication info: WO2006025138 - 2006-03-09	Applicant: MURATA MANUFACTURING CO (JP); TAKESHIMA TETSUO (JP); (+3) IPC: (IPC1-7): H04R17/00; G10K9/122; H01L41/08
6	HIGH SENSITIVITY, LOW NOISE PIEZOELECTRIC FLEXURAL SENSING STRUCTURE	Inventor: ZOU LICHUN (US); DENG KEN KAN (US) EC: Publication info: WO2005059472 - 2005-06-30	Applicant: WILCOXON RES INC (US); ZOU LICHUN (US); (+1) IPC: G01B5/28; G01B5/28; G01C (+1)
7	High sensitivity, low noise piezoelectric flexural sensing structure	Inventor: ZOU LICHUN (US); DENG KEN K (US)	Applicant:

EC: G01L1/16; G01L1/04C; (+1)	IPC: G01B5/28; G01L1/04; G01L1/16 (+6)
Publication info: US2005132816 - 2005-06-23	
3 SINGLE CRYSTAL PIEZOELECTRIC APPARATUS AND METHOD OF FORMING SAME	
Inventor: CLINGMAN DAN J; JACOT A DEAN	Applicant: BOEING CO (US)
EC: B32B37/14B; B32B38/18D; (+3)	IPC: B32B37/14; H01L41/09; H01L41/113 (+8)
Publication info: WO2005001950 - 2005-01-06	
5 Piezoelectric acoustic transducer	
Inventor: YOKOI YUKO (JP); TAJIMA KIYOTAKA (JP); (+1)	Applicant: MURATA MANUFACTURING CO (JP)
EC: H04R17/00	IPC: H04R17/00; G10K9/122; H01L41/083 (+4)
Publication info: US2004201326 - 2004-10-14	
7 PIEZOELECTRIC OSCILLATION GYROSCOPIC ELEMENT AND SENSOR	
Inventor: KIKUSHIMA MASAYUKI	Applicant: SEIKO EPSON CORP
EC:	IPC: G01P9/04; G01C19/56; G01P9/04 (+3)
Publication info: JP2005106481 - 2005-04-21	

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